

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Jung-Ho LEE, et al.

Art Unit:

1712

Serial No.

10/779,733

Examiner:

Filed:

February 18, 2004

Confirmation No.

2084

For:

METHOD OF FORMING A SILICON OXIDE

LAYER IN A SEMICONDUCTOR MANUFACTURING PROCESS

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.56

Commissioner for Patents Alexandria, VA 22313-1450

Sir:

Submitted herewith on Form PTO/SB08 (A and/or B) is a listing of a document(s) known to applicant in order to comply with applicant's duty of disclosure pursuant to 37 C.F.R. §1.56. These references correspond to the art cited during prosecution of parent applications Serial No. 09/686,624, having a filing date of October 12, 2000, or parent application Serial No. 10/278,992, filed October 24, 2002, on which applicant relies under 35 U.S.C. 120. Accordingly, copies of the references need not be submitted; 37 C.F.R. §1.98(d)(1).

The submission of any document herewith, which is not a statutory bar, is not intended as an admission that such document constitutes prior art against the claims of the present application. Applicant does not waive any rights to take any action that would be appropriate to antedate or otherwise remove as a competent reference any document which is determined to be a *prima facie* prior art reference against the claims of the present application.

The listed document(s) is/are being cited in compliance with 37 C.F.R. 1.97(b)(3): submission before the mailing date of the first action on the merits. [Box checked if applicable.]

	The foregoing document came to applicant's attention during the prosecution of
their corresp	onding Korean application. [Box checked if applicable.]
	<u>CERTIFICATION</u>
	The undersigned hereby certifies in accordance with 37 CFR §1.97(e)(1) that
each item o	of information contained in this Information Disclosure Statement was cited in a
communica	tion from a foreign patent office in a counterpart foreign application not more than
three (3) mo	onths prior to the filing of this Statement. [Box checked if applicable.]
	Applicant respectfully requests that the listed document(s) be considered by
the Examin	er and be made of record in the present application and that an initialed copy of
Form PTO-	1449 be returned in accordance with MPEP §609.
	FEE PAYMENT
□ The	fee mandated by 37 C.F.R. §1.17(p) is believed applicable. [Box checked if
applio	able.]
☐ Atta	ached is a check in payment of this fee (\$180.00). [Box checked if applicable.]
☐ Thi	s fee may be charged to Deposit Account No. 50-1645. (A duplicate copy of
this p	aper is enclosed.) [Box checked if applicable.]
	Respectfully submitted,
July 12, 20 Date	Suchus A - Stub REG. No. Eugene M. Lee, Registration No. 32,039

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DEPOSIT ACCOUNT CHARGE AUTHORIZATION

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-1645.

Any additional fee(s) necessary to effect the proper and timely filing of the above-paper may also be charged to Deposit Account No. 50-1645.

PTO/SB/08A (04-03)

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Substitute for form 1449/PTG?

Sheet 1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Co	mplete if Known	
Application Number	10/779,733	
Filing Date	February 18, 2004	
First Named Inventor	Jung-Ho LEE, et al.	
Art Unit	1712	•
Examiner Name		
Attorney Docket Number	253/006 CIP.2	

				DOCUMENTS	
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ^{2 (if known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		^{US-} 4,950,381	08-21-0990	TAKEUCHI, et al.	
		^{US-} 5,922,411	07-13-1999	SHIMIZU, et al.	
		^{US-} 5,614,271	03-25-1997	SHIBUYA, et al.	
•		^{US-} 5,665,643	09-09-1997	SHIN, et al.	
		^{US-} 5,738,911	04-14-1998	IMAMURA, et al.	
		^{US-} 5,770,260	06-23-1998	FUKUYAMA, et al.	
		US- 5,907,382	05-25-1999	KAJIURA, et al.	
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		^{US-} 5,989,945	11-23-1999	YUDASAKA, et al.	
		^{US-} 6,133,137	10-17-2000	USAMI	
		^{US-} 6,187,662 B1	02-13-2004	USAMI, et al.	
	<u> </u>	^{US-} 6,235,620 B1	05-22-2001	SAITO, et al.	
		^{US-} 6,261,883 B1	07-17-2001	KOUBUCHI, et al.	
		^{US-} 6,338,868 B1	01-15-2002	SHIBUYA, et al.	
		US-			

		FORE	IGN PATENT DOCU	MENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	
	ŀ	Country Code ³ Number ⁴ Kind Code ⁵ (<i>if known</i>)	MM-DD-YYYY	,,	Or Relevant Figures Appear	T
		EP 0 266 918	05-11-0988	HALUSKA		
		EP 0 296 433	12-28-1988	AYAMA, et al.		
		EP 0 315 953	05-17-1989	MAHONE		
		EP 0 552 852	07-28-1993	FUNAYAMA, et al		
		EP 0 611 067	08-17-1994	BANEY, et al		
		EP 0 749 155	12-18-1996	HALUSKA, et al.		

Examiner	Date	-
Signature	Considered	

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

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Sheet 2

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Art Unit	1712		
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Attorney Docket Number	253/006 CIP 2		

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	Number-Kind Code ^{2 (ff known)}			Figures Appear	
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		Country Code ³ Number ⁴ Kind Code ⁵ (if known)	MM-DD-YYYY		Or Relevant Figures Appear	T
		EP 0 825 231	02-25-1998	HAGIWARA, et al		
		EP 1 002 824	05-24-2000	SHIMIZU, et al.		
		JP 2000-58646*	02-25-2000	NAKAMURA		
		*w/English Abstract				
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Examiner Date	
Signature Considered	

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